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**RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1763**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Confirmation No.: 1605

OHMI et al. Art Unit: 1763

Application No.: 09/864,376 Examiner: R. Zervigon

Filed: May 25, 2001 Docket No.: 107176-00007

For: PLASMA PROCESSING APPARATUS AND PLASMA PROCESSING METHOD

AMENDMENT UNDER 37 C.F.R. § 1.116

Introductory Comments

Director of the U.S. PTO

P.O. Box 1450

Alexandria, Virginia 22313-1450

December 22, 2005

Sir:

In response to the Office Action dated September 28, 2005, please enter the following amendments:

TECH/389388.1